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I THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT APPLICATION of

Shinji Ohuchi et al.

Group Art Unit: 2822

Serial No.: 09/852,847

Examiner: Lewis, Monica

Filed: May 11, 2001

For: SEMICONDUCTOR DEVICE, MANUFACTURING METHOD OF

SEMICONDUCTOR DEVICE, STACK TYPE SEMICONDUCTOR DEVICE, AND MANUFACTURING METHOD OF STACK TYPE SEMICONDUCTOR DEVICE

RESPONSE TO ELECTION/RESTRICTION REQUIREMENT

Honorable Commissioner of Patents and Trademarks, Washington, D.C. 20231

Sir:

In response to the Office Action of February 25, 2002, Applicants elect the invention of Group I, Claims 1-8, drawn to a device. The election is without traverse.

Respectfully submitted,

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Dated: March 11, 2002